



#17/ Amold D (NE)
4.9.03

BOX AF

Docket No. 740819-408

C. Moore

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hiroaki NAKAOKA et al.

Serial No. 09/640,519

Filed: August 17, 2000

For: METHOD OF FABRICATING
SEMICONDUCTOR DEVICE

)
) Group Art Unit: 2818
) Examiner: David VU
)
) Date: April 3, 2003

RECEIVED
TO: [illegible]
FROM: [illegible]
DATE: 4/3/03
ROOM: [illegible]
[illegible signature]

AMENDMENT AFTER FINAL

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action mailed December 4, 2002, please consider the following amendments and remarks in connection with the above-identified application.